



SPC-PISCES Testbed Update May 2017

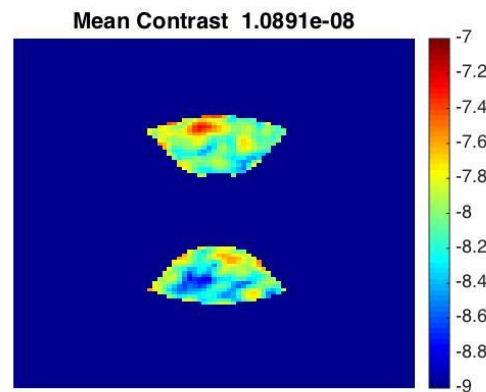
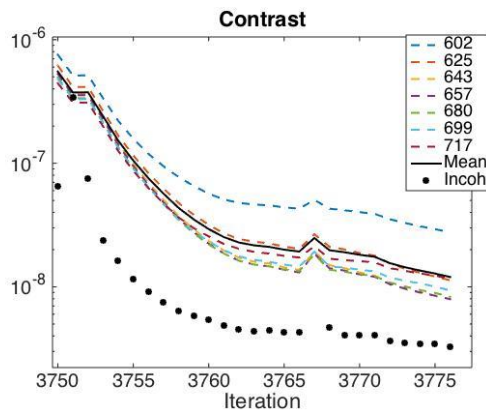
Camilo Mejia Prada
Jet Propulsion Laboratory
California Institute of Technology

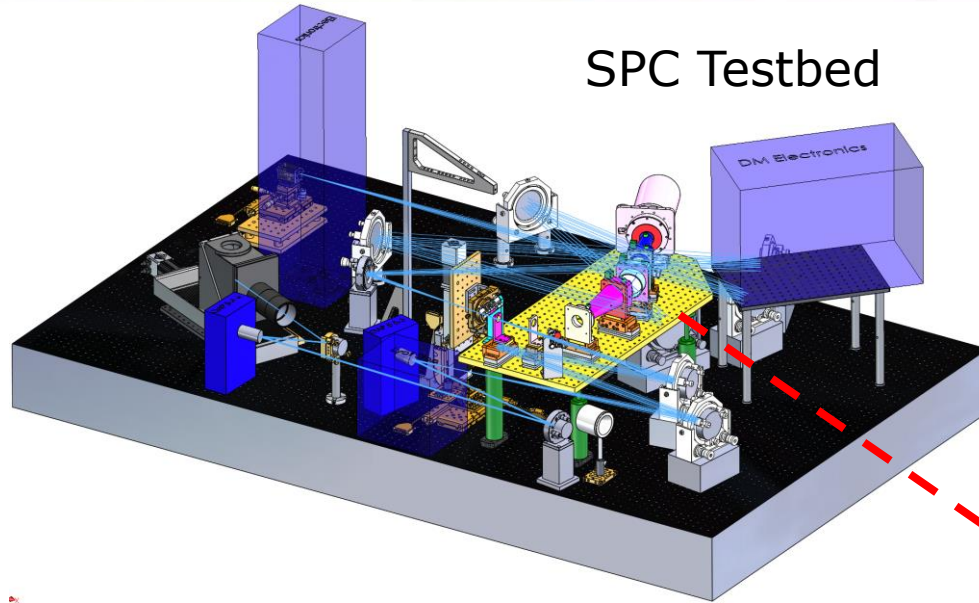
Objectives:

- Integrate PISCES to SPC Testbed at HCIT-2W
- Use PISCES with EFC for wavefront-control

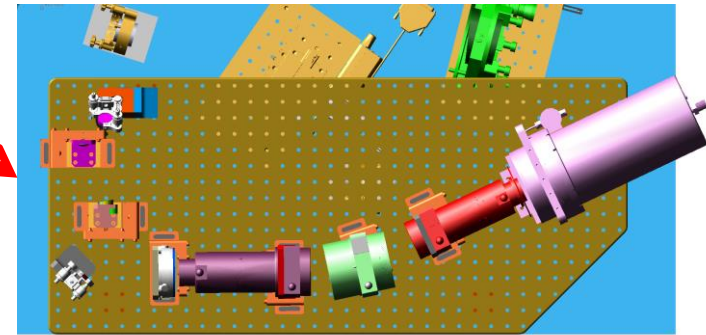
Plan:

- Align PISCES at HCIT-2W
- Test PISCES spectral calibration and registration
- Test PISCES remote acquisition and data reduction Pipeline
- Perform EFC using PISCES reduction pipeline in 18% band

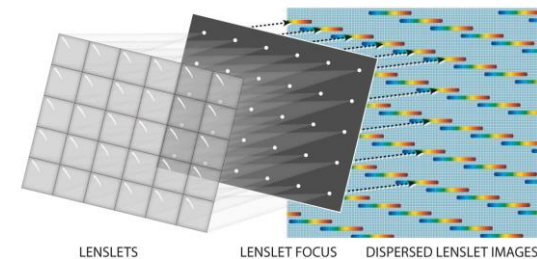
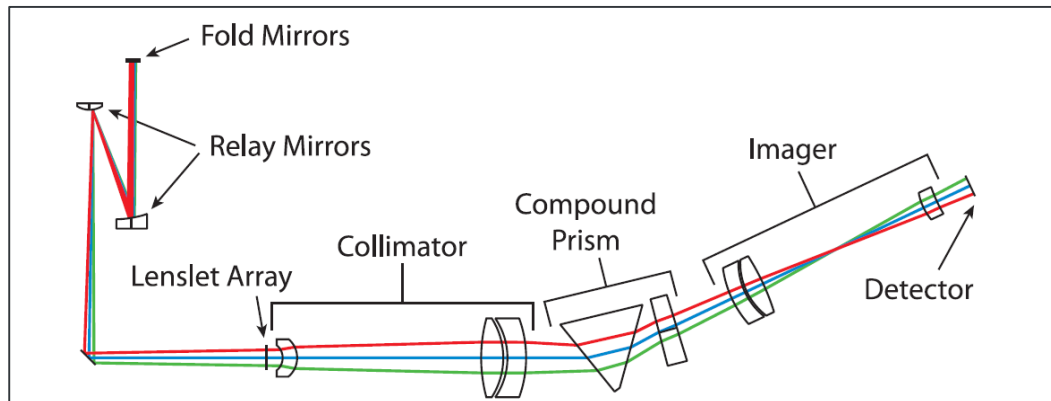




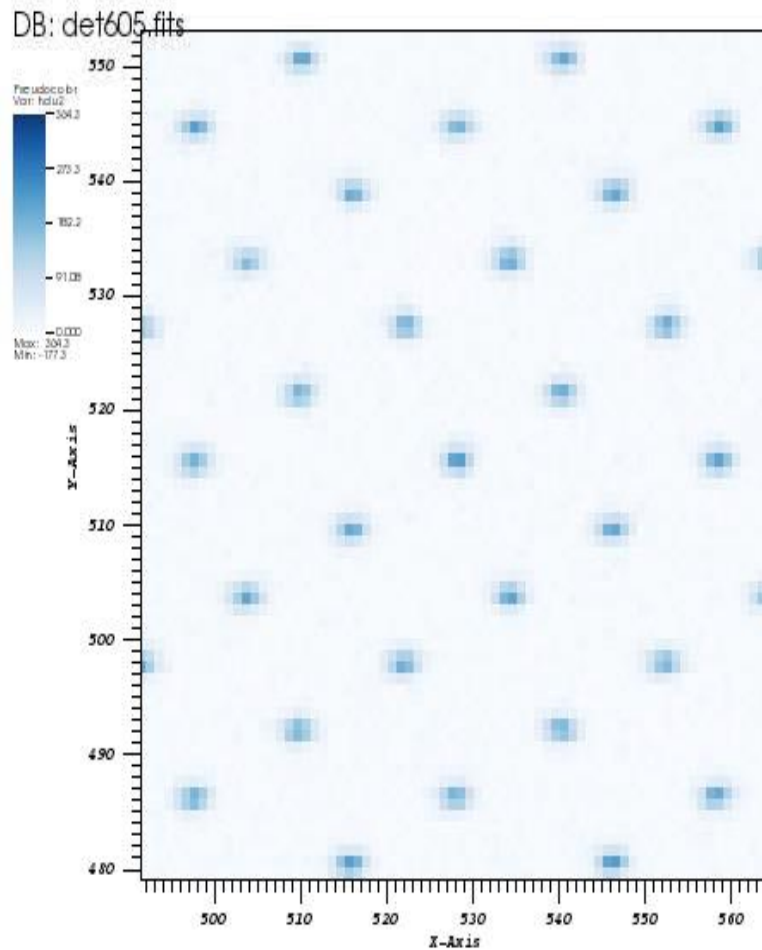
SPC Testbed- 2nd Floor



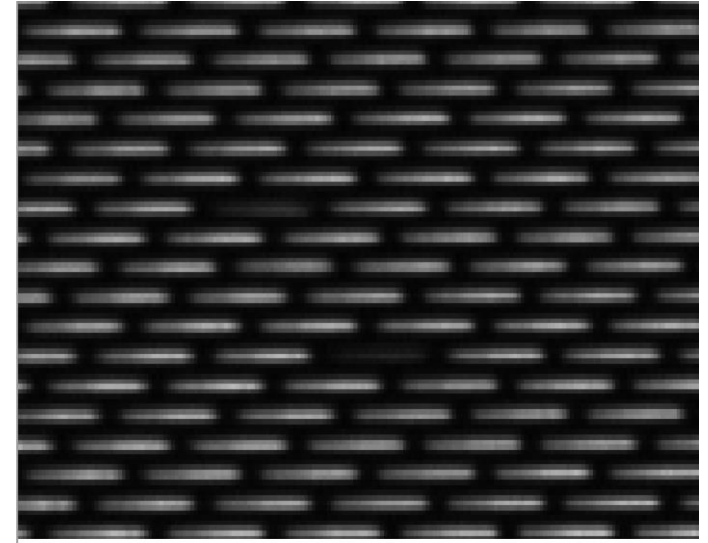
Optical Path



PISCES Microspectrum



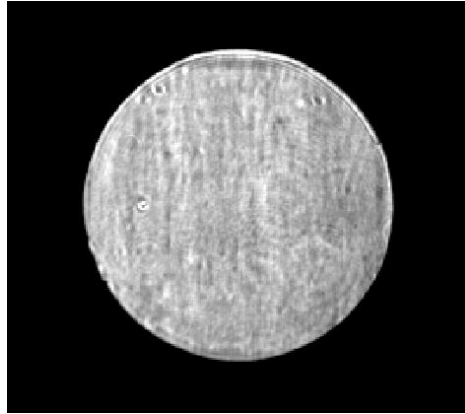
user:mitzo
Tue May 23 14:33:17 2017



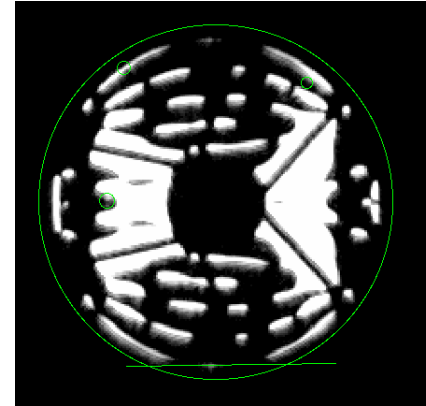
Testbed configuration



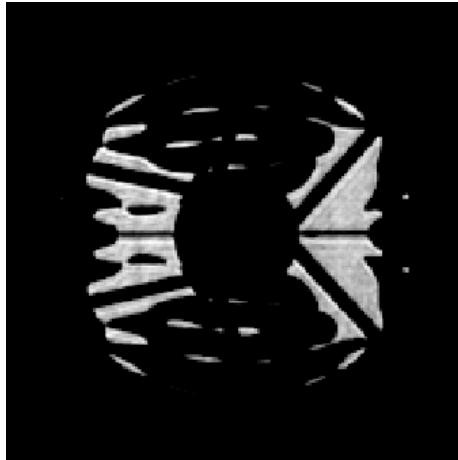
Pupil



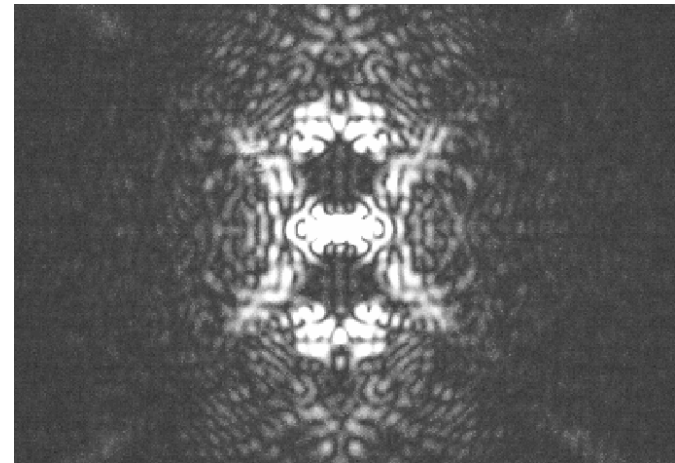
Mask



Mask + Lyot



PSF

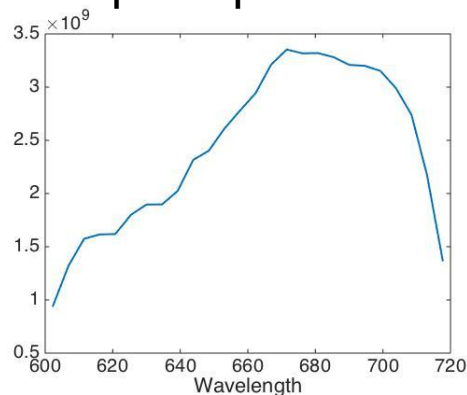


- Pupil errors are behind the SP mask.
- SP mask has small Low Order error.

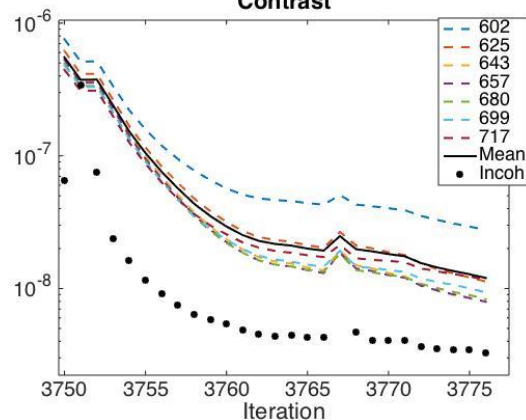
Run Broad band 18%, IFS



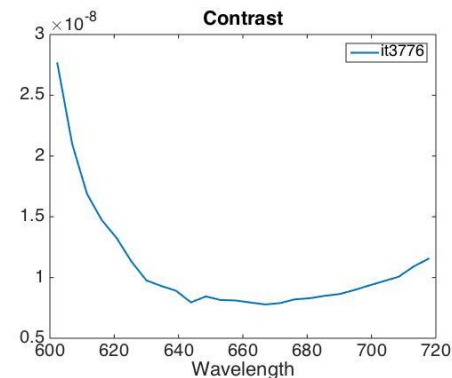
Input spectrum



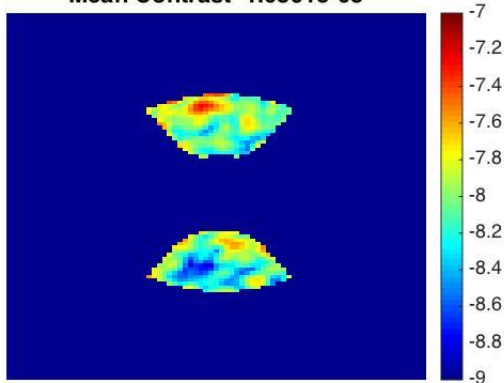
Contrast



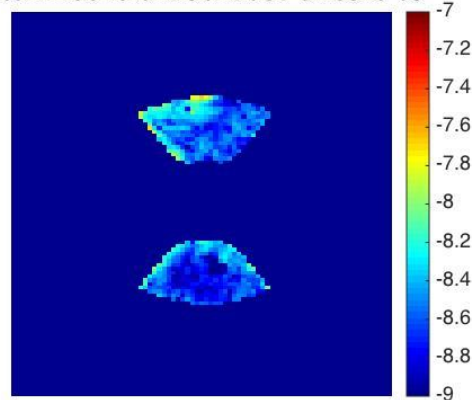
Contrast



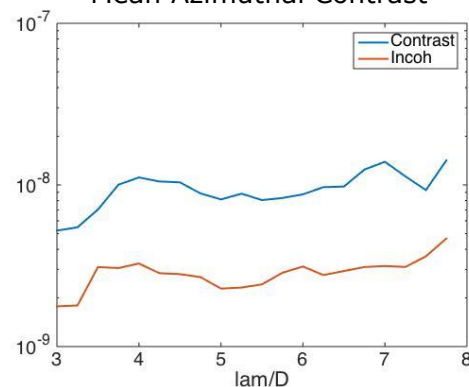
Mean Contrast 1.0891e-08



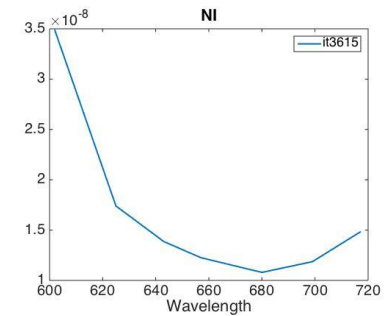
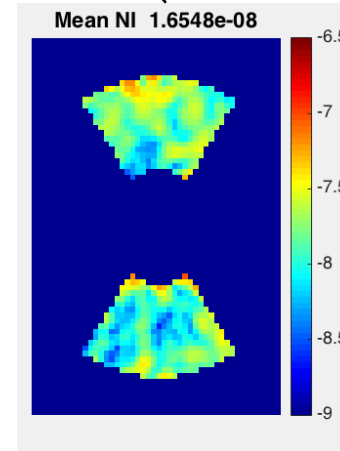
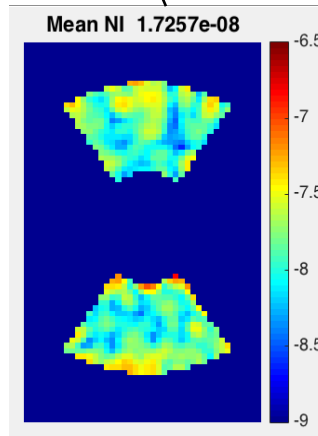
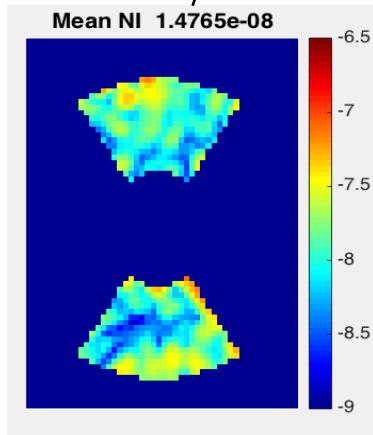
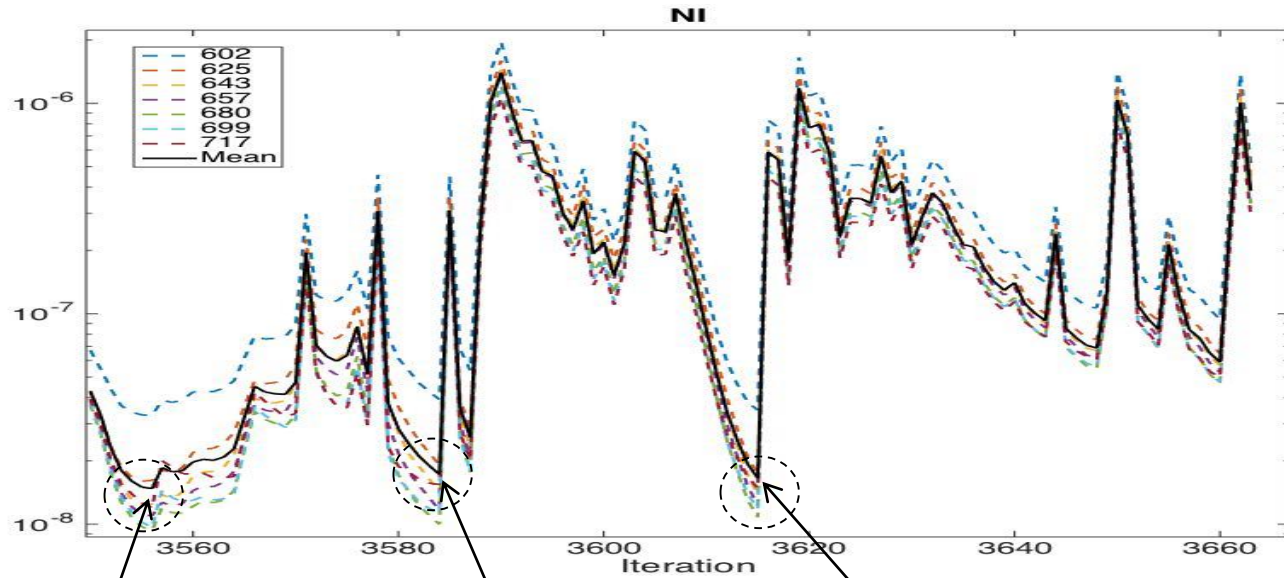
Mean Incoherent Contrast 3.2581e-09



Mean Azimuthal Contrast

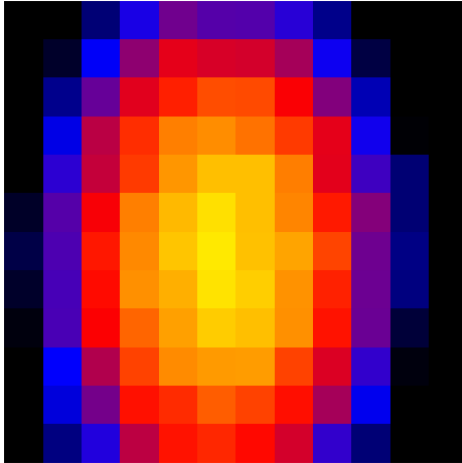


- 18% Control at 660nm
- Score: Two sides, 26 channels, 3-8 λ/D , 65°
- Control: Two sides, 7 channels, 2.5-9.5 λ/D , 75°
- PISCES optimal extraction

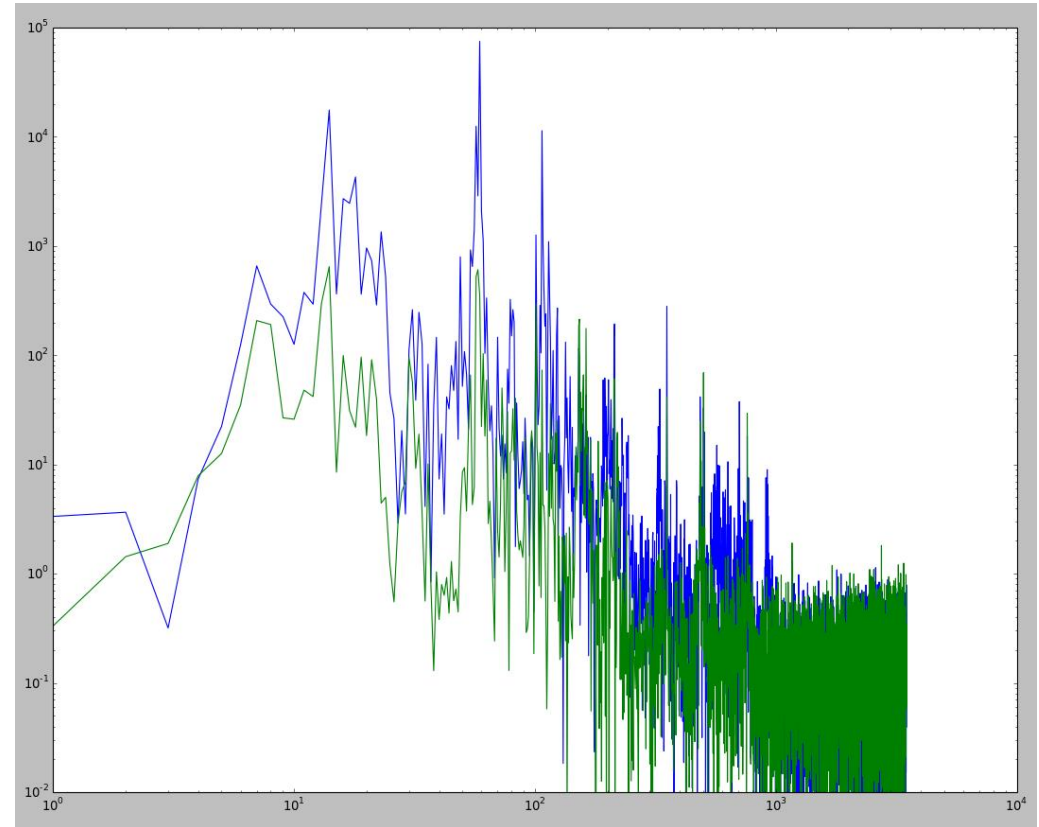


- 18% Control at 660nm

Centroid



PSD

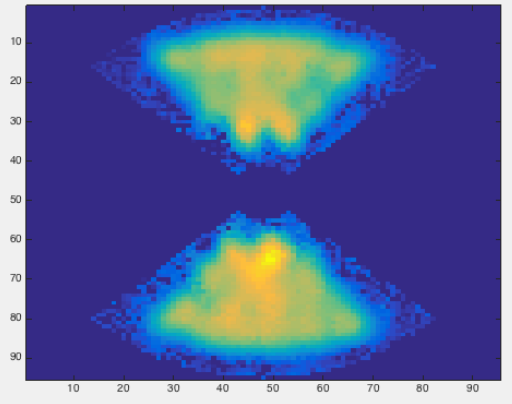


Jitter: (0.08,0.017) pixels rms

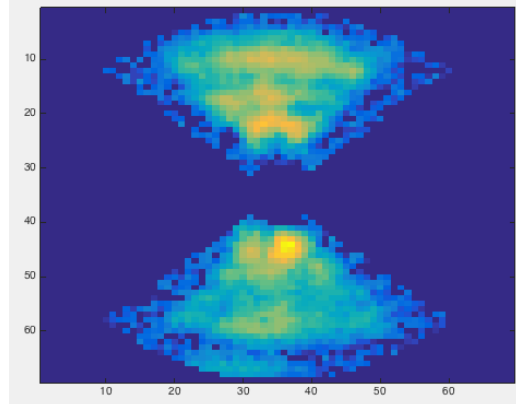
Probe amplitude comparison



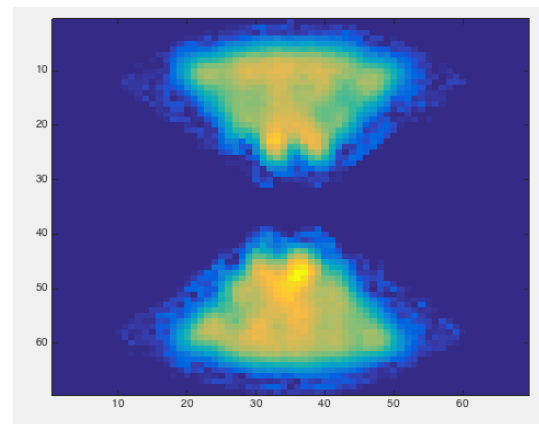
Imager



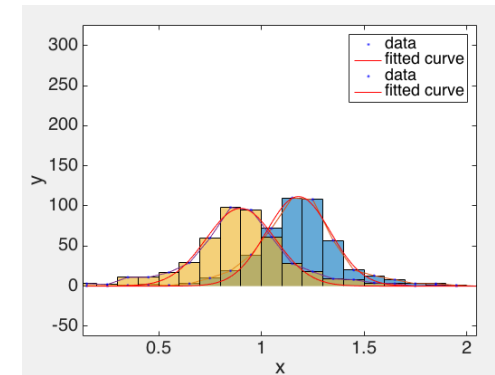
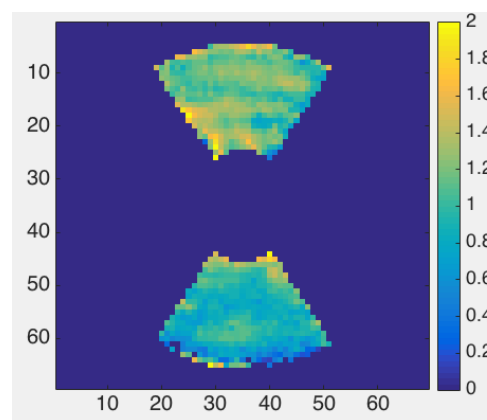
IFS



Imager IFS sampled



Ratio



```
General model Gauss1:
ha1(x) = a1*exp(-((x-b1)/c1)^2)
Coefficients (with 95% confidence bounds):
a1 = 111.6 (105.7, 117.6)
b1 = 1.18 (1.171, 1.19)
c1 = 0.2207 (0.2071, 0.2344)

ha2 =

General model Gauss1:
ha2(x) = a1*exp(-((x-b1)/c1)^2)
Coefficients (with 95% confidence bounds):
a1 = 96.95 (91.34, 102.6)
b1 = 0.8992 (0.8879, 0.9105)
c1 = 0.2387 (0.2227, 0.2546)

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